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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Joachim MAI, et al.

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For : METHOD AND DEVICE FOR ION BEAM  
PROCESSING OF SURFACES

Group Art Unit : UNKNOWN

Examiner : UNKNOWN

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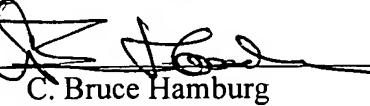
INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is an Information Disclosure Citation together with copies of the documents referred to therein.

Respectfully submitted,

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